

AMENDMENT UNDER 37 C.F.R. § 1.116  
EXPEDITED PROCEDURE  
GROUP 2886  
**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of	Docket No: Q85096
Masamichi INENAGA, et al.	
Appln. No.: 10/516,693	Group Art Unit: 2886
Confirmation No.: 6877	Examiner: Isiaka O. Akanbi
Filed: December 6, 2004	
For: WAFER PRE-ALIGNMENT APPARATUS AND METHOD	

**AMENDMENT UNDER 37 C.F.R. § 1.116**

**MAIL STOP AF**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated February 11, 2008, please amend the above-identified application as follows on the accompanying pages.

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